

IN THE UNITED STATES OF AMERICA PATENT AND TRADEMARK OFFICE

APPLICANTS: Tianhong Cui, Jing Wang & Yongjun Zhao

SERIAL NO.: 10/648,927

FILING DATE: August 27, 2003

TITLE: Polymer Based Tunneling Sensor

DOCKET NO.: 16675/97145-00

CERTIFICATE OF MAILING

Date of Deposit: December 8, 2003

I hereby certify that the following attached paper or fee:

- Information Disclosure Statement (6 pgs.);
- Copies of Cited Non-Patent References 22 References;
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Tina G. Matz



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INFORMATION DISCLOSURE STATEMENT

The following sections are being submitted for this Information Disclosure Statement:

- 1. Preliminary Statements
- 2. FORM PTO -1449 (Modified)
- 6. Copies Of Listed Information Items Accompanying This Statement
- 9. Concise Explanation Of English Language Listed Information Items (Optional)
- 10. Identification Of Person(s) Making This Information Disclosure Statement

Section 1. Preliminary Statements

Applicant submits herewith patents, publications or other information of which they are aware, which they believe may be material to the examination of this application and in respect of which there may be a duty to disclose.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), an admission that the information cited is, or is considered to be, material to patentability or that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Notice of January 9, 1992, 1135 O.G. 13-25, at 25.

PTO/SB/08a (06-03) Approved for use through 07/31/2003. OMB 0651-0031

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Spesitive for (Gir 1449A/PTO

Application Number 10/648,927

Filling Date August 27, 2003

First Named Inventor Tianhong Cui, et al

Art Unit Examiner Name

(Use as many sheets as necessary)
Sheet 1 of 4 Attorney Docket Number 16675/97145-00

			U. S. PATENT	DOCUMENTS	
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ^{2 (f known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	P:≱ges, Columns, Lines, Where Rulevant Passages or Relevant Figures Appear
		^{US-} 5,502,667	03/26/1996	Bertin, et al	
		⁰⁸⁻ 5.563.344	10/08/1996	Kaiser, et al	
		^{US-} 5,587,128	12/24/1996	Wilding, et al	
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		^{US-} 6,393,913	05/28/2002	Dyck, et al	
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	FOREIGN PATENT DOCUMENTS									
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ Number ⁴ 'Kind Code ⁸ (<i>if known</i>)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	τ•				
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This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Substitute 4	1649B/PTO				Complete if Known	
				Application Number	10/648,927	
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STAT	ement by /	appli	Cant	First Named Inventor	Tianhong Cui, et al	
				Art Unit		
	(Use as many sheets as	necessary))	Examiner Name		
Sheet	2	of	4	Attorney Docket Number	16675/97145-00	

		NON PATENT LITERATURE DOCUMENTS
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue numtier(s), publisher, city and/or country where published.
	l	ROOS, N., LUXBACHER, T., GILSNER, T., PFEIFFER, K., SCHULZ, H. & SCHEER, HC.; Nanoimprint Lthography with a Commercial 4 Inch Bond System for Hot Embossing, Presented at SPIE'S Microlithography, 27-28 February 2001, Santa Clara, CA
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>	/	BECKER, H. & HEIM, U; Silicon as Tool Material for Polymer Hot Embossing; Proceedings MEMS 99; 1999; pgs. 228-231
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translution is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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duction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

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				Application Number	10/648,927			
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Sheet	3	of	4	Attorney Docket Number	16675/97145-00			

		NON PATENT LITERATURE DOCUMENTS					
Examiner nitials* Cite No.1 Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue numt er(s), publisher, city and/or country where published.							
	^	BASKI, A., ALBRECHT, T. & QUATE, C.; Tunnelling Accelerometer; Journal of Micro-Scopy, 152; pgs. 73-76, 1988					
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Section 6. Copies of Listed Information Items Accompanying This Statement

Copies of cited references listed are attached.

Section 9. Concise Explanation Of English Language Listed Information Items (Optional)

Section 10. Identification of Person(s) Making THIS INFORMATION DISCLOSURE STATEMENT

The person making this statement is the attorney who signs below on the basis of the information in the attorney's file.

Reg. No.: 38,882

Tel. No.: (225) 248-2106

LANCE A. FOSTER

JONES, WALKER, WAECHTER, POITEVENT,

CARRÈRE & DENÈGRE, L.L.P. 4TH FLOOR, FOUR UNITED PLAZA 8555 UNITED PLAZA BOULEVARD BATON ROUGE, LOUISIANA 70809